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**** CONTINUING DATA *******
 This application is a 371 of PCT/JP05/09305 05/17/2005

**** FOREIGN APPLICATIONS *******
 JAPAN 2004-156968 05/27/2004

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature <i>[Signature]</i> Initials <i>EH</i>	STATE OR COUNTRY JAPAN	SHEETS DRAWING 2	TOTAL CLAIMS 4	INDEPENDENT CLAIMS 2
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ADDRESS
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TITLE
Silicon layer production method and solar cell production method

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